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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s): Woo Sik Yoo
Assignee: WaferMasters, Inc.
Title: Method for H2 Recycling In Semiconductor Processing System
Serial No.: 09/828,518 Filing Date: April 6, 2001
Examiner: Olivia T. Luk Group Art Unit: 2812
Docket No.: M-8608US

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POWER OF ATTORNEY BY ASSIGNEE OF ENTIRE INTEREST

Sir:

The above-identified assignee, hereby revokes all powers of attorney previously given and appoints the attorney(s) and/or agent(s) identified below to prosecute the above-identified application and to transact all business in the United States Patent and Trademark Office in connection therewith:

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ASSIGNEE CERTIFICATION UNDER 37 CFR 3.73(B)

The undersigned representative of the above-identified assignee certifies that the above-identified assignee is the assignee of the entire right, title and interest in the above-identified patent application/patent by virtue of a chain of title from the inventor(s) of the above-identified patent application/patent to the above-identified assignee as shown below:

1. From: Woo Sik Yoo To: WaferMasters, Inc.

The document was submitted to the Patent and Trademark Office for recordation on April 6, 2001 . A copy of the document is attached.

The undersigned (whose title is supplied below) is empowered to sign this certificate on behalf of the above-identified assignee.

Date: 08/20/02

By: 

(Signature)

Name: SHINTARO FUJIMOTO
(Printed or Typed Name)

Title: Chief Operating Officer